RECEIVED CENTRAL FAX CENTER JAN 2 7 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No	10/705,371
Filing Date	
Inventor	Brian F. Cron
Assignee	Micron Technology Inc
Group Art Unit	2722
Examiner Attorney Docket No	Migo-9490
Title: Methods for Conditioning Surfaces	o of Polishing Pade After Chemical
Mechanical Polishing	s of Polishing Paos After Chemical-
Commissioner for Patents	
P.O. Box 1450	
Alexandria, VA 22313-1450	
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CERTIFICATE OF FACSIMILE TRAN	SMISSION UNDER 37 CFR § 1.8
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Certificate of Facsimile Trans Page 12.22	
2. Response to November 12, 2004 Office Action	
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Dated: Yawary 27, 2005 By:	Muriel G. Dunnigan
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FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: //2/05

By: David G. Latwesen, Ph.D. Telephone No. (509) 624-4276

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Application Serial No.	10/705,371
Confirmation No.	4350
Confirmation No	November 10, 2003
Inventor	Brian E. Cron
Assignee	Micron Technology, Inc.
Group Art Unit	3/23
Evaminer	Anthony Ojini
Attorney's Docket No.	Ml22-2430
Customer No.	02156/
Title: Methods for Conditioning Surfaces Polishing	of Polishing Pads After Chemical-Mechanical

RESPONSE TO NOVEMBER 12, 2004 OFFICE ACTION

To:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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AMENDMENTS

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